

Docket No.: 070759-0043

PATENT

Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yasuhiro WATANABE, et al.

Application No.: 10/575,680

Customer No.: 20277

Filed: April 13, 2006

Confirmation No.: 4618

Group Art Unit: 2828

Examiner: ZHANG, Yuanda

Title: TWO-BEAM SEMICONDUCTOR LASER APPARATUS

REQUEST FOR RECONSIDERATION UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed on September 29, 2009, having a three-month shortened statutory period for reply set to expire on December 29, 2009, Applicants respectfully request reconsideration in view of the following remarks:

Remarks begin on page 2 of this paper.